

Notice of References Cited	Application/Control No. 10/717,316	Applicant(s)/Patent Under Reexamination ROSENCWAIG ET AL.	
	Examiner Roy M. Punnoose	Art Unit 2877	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-5,652,657	07-1997	Yoshii et al.	356/394
	C	US-6,038,015	03-2000	Kawata, Shintaro	355/67
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	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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	N					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
*	U	K. Imen et al "Laser assisted micron scale particle removal," App. Phys. Lett., Vol. 58, No. 2, 14 January 1 991 ,pp. 203-205.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.